

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: David W. Sherrer and Gregory A. Teneyck
Group: 1772 Confirmation No: 8879
Application No.: 09/519,165 Examiner: William P. Watkins, III
Filed: March 6, 2000
For: *Single Mask Lithographic Process for Patterning Multiple Types
Of Surface Features*

CERTIFICATE OF MAILING

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Board of Patent Appeals and Interferences, Assistant Commissioner for Patents, Washington, D.C. 20231.

By: *Deborah Celeste* Date: *January 24, 2003*
Deborah Celeste Date

PETITION FOR ONE MONTH EXTENSION OF TIME UNDER 37 CFR 1.136(a)

Board of Patent Appeals and Interferences
Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a response to the Office Action dated September 25, 2002 issued in the above-identified application. Please extend the due date for response for one month, from December 25, 2002 to January 25, 2003.

In lieu of filing a response, Applicants enclose a Notice of Appeal.

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Authorization is hereby given to charge Deposit Account No. 50-0369 in the amount of \$430 to cover the one-month extension fee in the amount of \$110 and the Notice of Appeal fee in the amount of \$320 and any additional fees that may be required.

Dated: 1/24/03

Respectfully submitted,

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